

INFORMATION DISCLOSURE CITATION

Atty. Docket No. 07303.0035	Serial No. 09/832,990
Applicant Alex Ka Tim POON	
Filing Date April 12, 2001	Group: 2851

U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate	
HN	4,198,159	15Apr80	Cachon				
	4,525,852	25Jun85	Rosenberg				
	4,532,426	30Jul85	Reeds				
	4,694,477	15Sep87	Siddall				
	4,891,526	02Jan90	Reeds				
	5,566,584	22Oct96	Briganti				
HN	5,903,085	11May99	Karam				

FOREIGN PATENT DOCUMENTS							
	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
HN	Kazuya Okamoto et al., "High-Throughput E-Beam Stepper Lithography," Solid State Technology, pp. 118-122 (2000).

Examiner H. Nguyen	Date Considered 12/10/02
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	
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